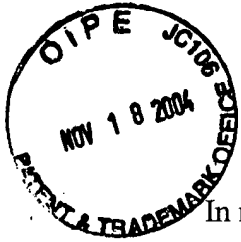


IFW

03500.017456

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KAZUHIRO KAGAMI ET AL.

Application No.: 10/627,645

Filed: July 28, 2003

For: BASE PATTERN FORMING
MATERIAL FOR ELECTRODE
AND WIRING MATERIAL
ABSORPTION, ELECTRODE
AND WIRING FORMING
METHOD, AND METHOD OF
MANUFACTURING IMAGE
FORMING APPARATUS

Examiner: H. M. Lee

Group Art Unit: 2823

November 15, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

A. Introductory Comments

In response to the Office Action dated August 13, 2004, please amend the application as follows and consider the following remarks.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

November 15, 2004
(Date of Deposit)

Jason M. Okun
(Name of Attorney for Applicants)

November 15, 2004
Date of Signature